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### (54) Metal-polishing liquid and chemical-mechanical polishing method using the same

(57) A metal-polishing liquid contains at least one heterocyclic compound having from one to three nitrogen atom as heteroatoms in a molecule; and colloidal silica having a surface partially covered with aluminum. A chemical-mechanical polishing method contains processes of supplying the metal-polishing liquid to a polish-

ing pad on a polishing platen; rotating the polishing platen; relatively moving the polishing pad while the polishing pad is contacted with a surface to be polished of an object to be polished; and polishing the surface to be polished of the object to be polished.



# **EUROPEAN SEARCH REPORT**

Application Number EP 07 00 2005

Catagory   Citation of document with indication, where appropriate, of relevant passages   Catagory   Citation of document with indication, where appropriate, of relevant passages   Catagory   Cat		
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The Hague 24 July 2009 Matthijssen,	1, J-J	
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## **EUROPEAN SEARCH REPORT**

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